	OSURE STATEMENT 7(c))	Docket No. 50T5690.01								
In Re Application Of: Tenko Yamashita										
Serial No.	Filing Date	Examiner	Group Art Unit							
Unassigned	Filed Herewith	Unassigned	Unassigned							
Title: SILICON-ON INSULATOR (SOI) SUBSTRATE HAVING DUAL SURFACE CRYSTALLOGRAPHIC										
ORIENTATIONS AND METHOD OF FORMING SAME										
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450										
_		FR 1.97(b)								
1. In Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.										
	37 C	CFR 1.97(c)								
2. The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:										
☐ the statem	nent specified in 37 CFR 1.97(e);									
	OR									
☐ the fee se	t forth in 37 CFR 1.17(p).									

4

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT Docket No. (Under 37 CFR 1.97(b) or 1.97(c)) 50T5690.01 In Re Application: Tenko Yamashita Serial No. Filing Date Examiner **Group Art Unit** Unassigned Filed Herewith Unassigned Unassigned SILICON-ON INSULATOR (SOI) SUBSTRATE HAVING DUAL SURFACE CRYSTALLOGRAPHIC ORIENTATIONS AND METHOD OF FORMING SAME Payment of Fee (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p)) A check in the amount of is attached. The Director is hereby authorized to charge and credit Deposit Account No. 50-1047 as described below. Charge the amount of Credit any overpayment. Charge any additional fee required. EXPRESI Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail I certify that this document and authorization to charge deposit I certify that this document and fee is being deposited account is being facsimile transmitted to the United States 3/12/04 with the U.S. Postal Service on as first, class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box Patent and Trademark Office (F: 1450, Alexandria, VA 22313-1450. (Date) Signature of Person Mailing Correspondence Signature MARJOME SCAMP Typed or Printed Name of Person Signing Certificate Typed or Printed Name of Person Mailing Certificate *This certificate may only be used if paying by deposit account. Dated: March 12, 2004 Signature Keum J. Park Reg. No. 42,059 Mayer Fortkort & Williams, PC 251 North Avenue West, 2nd Floor Westfield, NJ 07090 Tel.: 908-518-7700 cc:

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)		Application Number		
50T5690.01		Unassigned		
Applicant(s)	``			
Tenko Yamashita	ŕ			
Filing Date		Group Art Unit		
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_				U.S. PAT	ENT DOCUMENTS					
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS	FILING	DATE	
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			<u> </u>	FOREIG	N PATENT DOCUME	ENTS	L	1		
		DOCUMENT NUMBER	DATE			<u> </u>	Translation			
	REF	DOCUMENT NUMBER		<u>.</u>	COUNTRY	CLASS	SUBCLASS	YES	NO	
				OTHER	DOCUMENTS (Inc.	luding Author, Title	, Date, Pertinent Po	ages, Etc.)		
		Momose, H.S. et al., "I. Devices, Vol. 50, No. 4,	5-nm Gate Oxide	CMOS on					ectron	
		Devices, Vol. 50, No. 4,	April 2003, pp. 1	001-1008.						
	\dashv							<u>.</u>	, .	
EXAMINE	R	1		-	DATE CONSIDERE	ED				

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.